



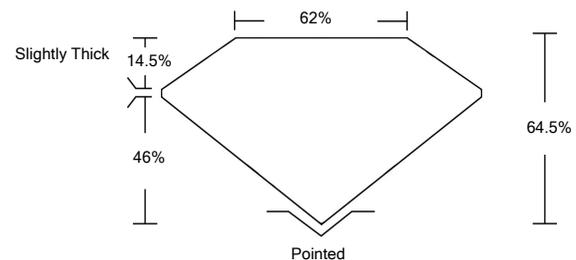
LG506180983

LABORATORY GROWN DIAMOND REPORT

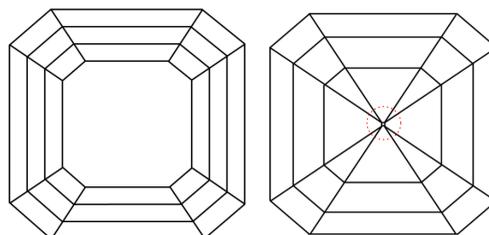
December 11, 2021	
IGI Report Number	LG506180983
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	8.31 X 8.30 X 5.35 MM
GRADING RESULTS	
Carat Weight	3.18 CARATS
Color Grade	F
Clarity Grade	VVS 2
ADDITIONAL GRADING INFORMATION	
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LABGROWN IGI LG506180983

Comments: As Grown - No indication of post-growth treatment
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) process
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS

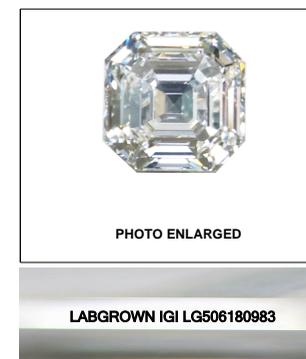


KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

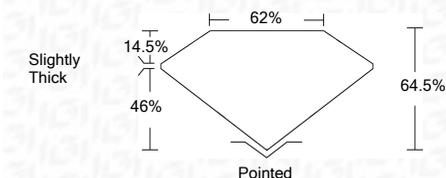
GRADING SCALES

COLOR GRADING SCALE	CL	NC	FT	VL	LT	
	COLORLESS D-F	NEAR COLORLESS G-J	FAINT K-M	VERY LIGHT N-R	LIGHT S-Z	
CLARITY (10x) GRADING SCALE	FL	IF	VVS	VS	SI	I
	FLAWLESS INTERNALLY FLAWLESS	VERY VERY SLIGHTLY INCLUDED	VERY SLIGHTLY INCLUDED	SLIGHTLY INCLUDED	INCLUDED	INCLUDED



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IGI

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IGI Report No. LG506180983	
SQUARE EMERALD CUT	
8.31 X 8.30 X 5.35 MM	
Carat Weight	3.18 CARATS
Color Grade	F
Clarity Grade	VVS 2
Depth	64.5%
Table	62%
Girdle	Slightly Thick
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LABGROWN IGI LG506180983
Comments:	
As Grown - No indication of post-growth treatment This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) process Type IIa	